

Center for TCC 1-16-09

~~17572009~~

**In re Application of:**

Gicquel, *et al.*

**Serial No.: 10/541,970**

**Filed: July 11, 2005**

## For: High-Speed Diamond Growth Using a Microwave Plasma in Pulsed Mode

**Confirmation No.: 8766**

**Examiner: Stouffer, Kelly M.**

**Group Art Unit: 1792**

Mail Stop AF  
Commissioner for Patents  
P.O. Box 1450  
Alexandria, Virginia 22313

**RESPONSE TO FINAL OFFICE ACTION MAILED JULY 28, 2008**

Dear Sir/Madam:

In response to the final Office action mailed July 28, 2008, Applicant submits the following amendments and remarks.

The Listing of the Claims begins on page 2 of this paper and replaces all prior listings and versions of the claims.

Remarks begin on page 5.